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09/502340 02/10/00

	Subclass	ISSUE CLASSIFICATION
Class		

**PATENT NUMBER**

**U.S. UTILITY Patent Application**

**O.I.P.E.T.**

**PATENT DATE**

SCANNING

94

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/502340	YES	117	13	1765	Anderson

REVIEWERS  
Robert Fuerhoff  
Steven Kimbel

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Method and apparatus for controlling diameter of a silicon crystal  
in a locked seed lift growth process

PTO-2040  
12/89

## ISSUING CLASSIFICATION

Continued on Issue Slip Inside File Jacket

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